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ISSN: 2349-5162 | ESTD Year: 2014 | Monthly Issue



JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

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Ref No: JETIR / Vol 6 / Issue 1 / 032

Confirmation Letter

To,

Dr. N.Balakrishnan

Published in : Volume 6 | Issue 1 | 2019-01-16



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research.

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Published in : Volume 6 | Issue 1 | 2019-01-16

Publication Date: 2019-01-16 Page No : 178-187

Published URL: http://www.jetir.org/view?paper=JETIR2003032

: Dr. N.Balakrishnan, C.Prabakaran

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